INTERNATIONAL GEMOLOGICAL INSTITUTE

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LABORATORY GROWN DIAMOND REPORT

August 29, 2024

IGI Report Number	LG649405814
Description	LABORATORY GROWN DIAMOND
Shape and Cutting Style	CUT CORNERED RECTANGULAR MODIFIED BRILLIANT
Measurements	8.27 X 5.66 X 3.70 MM

GRADING RESULTS

Carat Weight	1.53 CARAT
Color Grade	G
Clarity Grade	VS 1

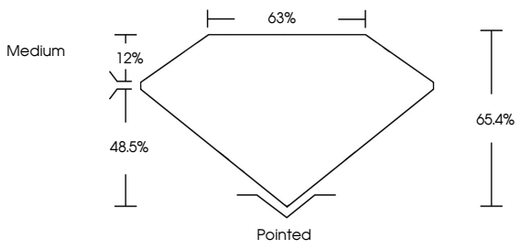
ADDITIONAL GRADING INFORMATION

Polish	EXCELLENT
Symmetry	EXCELLENT
Fluorescence	NONE
Inscription(s)	LG649405814

Comments: This Laboratory Grown Diamond was created by Chemical Vapor Deposition (CVD) growth process.
Type IIa

LG649405814
Report verification at igi.org

PROPORTIONS





Sample Image Used

COLOR

D	E	F	G	H	I	J	Faint	Very Light	Light

CLARITY

IF	VVS 1 - 2	VS 1 - 2	SI 1 - 2	I 1 - 3
Internally Flawless	Very Very Slightly Included	Very Slightly Included	Slightly Included	Included

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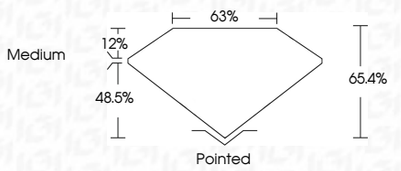
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IGI

August 29, 2024
IGI Report No LG649405814
CUT CORNERED RECT. MODIFIED BRILLIANT
8.27 X 5.66 X 3.70 MM
Carat Weight 1.53 CARAT
Color Grade G
Clarity Grade VS 1
Depth 65.4%
Table 63%
Girdle Medium
Culet Pointed
Polish EXCELLENT
Symmetry EXCELLENT
Fluorescence NONE
Inscription(s) LG649405814
Comments:
This Laboratory Grown Diamond was created by Chemical Vapor Deposition (CVD) growth process.
Type IIa